

APR 12 2006 P. 01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : RICHARDSON
Serial No. : 10/795,884
Filed : 03/8/2004
TC/A.U. : 2882
Examiner : THOMAS
Docket No. : UCF287DIV
Customer No. : 23717
For : EUV, XUV, AND X-RAY WAVELENGTH SOURCES
CREATED FROM LASER PLASMA PRODUCED FROM
LIQUID METAL.

Commissioner of Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313-1450

SENT BY FACSIMILE TO 571 273-8300

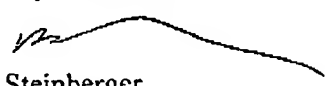
Honorable Commissioner:

I enclose the following papers:

1. Amendment Response and Arguments
2. Terminal Disclaimer
3. Government Fee for \$65 for Terminal Disclaimer

Please enter the above correspondence.

Respectfully submitted,

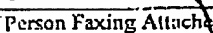

Brian S. Steinberger
Attorney at Law
PTO Registration No. 36,423
101 Brevard Avenue
Cocoa, Florida 32922
(321) 633-5080 Facsimile (321) 633-9322

CERTIFICATE OF FACSIMILE

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited on the date shown below by Facsimile to (571) 273-8300 addressed to the: Commissioner of Patents and Trademarks, P.O. Box 1450 Alexandria, VA 22313-1450.

4/12/06
Date

Brian S. Steinberger
(Name of Person Faxing Attached Papers)


(Signature of Person Faxing Attached Papers)